

*Cont*  
*A1*

6. (Amended) The ceramic substrate according to claim 1,  
wherein said conductor layer is any of a chuck top electrode, a guard electrode and a  
ground electrode.

Please add new Claims 7-16 as follows:

*X* (New) The ceramic substrate according to claim 2,  
wherein the thickness of said ceramic substrate is 25 mm or less.

8. (New) The ceramic substrate according to claim 2,  
wherein said conductor layer is an electrostatic electrode.

*A2*  
9. (New) The ceramic substrate according to claim 3,  
wherein said conductor layer is an electrostatic electrode.

10. (New) The ceramic substrate according to claim 7,  
wherein said conductor layer is an electrostatic electrode.

11. (New) The ceramic substrate according to claim 2,  
wherein said conductor layer is a resistance heating element.

12. (New) The ceramic substrate according to claim 3,  
wherein said conductor layer is a resistance heating element.

13. (New) The ceramic substrate according to claim 7,  
wherein said conductor layer is a resistance heating element.

14. (New) The ceramic substrate according to claim 2,  
wherein said conductor layer is any of a chuck top electrode, a guard electrode and a  
ground electrode.

15. (New) The ceramic substrate according to claim 3,  
wherein said conductor layer is any of a chuck top electrode, a guard electrode and a  
ground electrode.